

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE
FABRICATION

Application Number :

Confirmation Number:

First Named Applicant: June Cline

Attorney Docket Number: BUR920040122US1

Art Unit:

Examiner:

Search string: (6676800 or 6318384 or 6235214 or 6127278 or 6020269 or 5807789).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|----------------|------|-------|----------|
| | 1 | 6676800 | 2004-01-13 | Festa et al | | | |
| | 2 | 6318384 | 2001-11-20 | Khan et al | | | |
| | 3 | 6235214 | 2001-05-22 | Deshmukh et al | | | |
| | 4 | 6127278 | 2000-10-03 | Wang et al | | | |
| | 5 | 6020269 | 2000-02-01 | Wang et al | | | |
| | 6 | 5807789 | 1998-09-15 | Chen et al | | | |

Signature

| Examiner Name | Date |
|---------------|------|
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